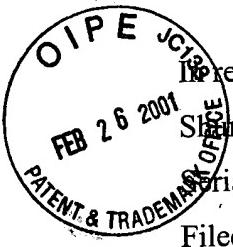


- 1 -

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re PATENT application of:

Shunpei YAMAZAKI et al.

Serial No. 09/295,607

Filed: 04/22/1999

For: SEMICONDUCTOR DEVICE HAVING

ALUMINUM NITRIDE FILM

Art Unit: 2811

Examiner: S. Loke

23/Pupp  
IDS  
Leys  
3/2/01

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 2/23/2001.

INFORMATION DISCLOSURE STATEMENT AND  
SUPPLEMENTAL TO INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

**BEST AVAILABLE COPY**

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-199, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The enclosed references Japanese Patent Laid Open Nos. 01-156725 and 53-027483 were submitted with abstract translations on December 29, 1999. Full translation are being submitted herewith.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

Respectfully submitted,

Jeffrey L. Costellia  
Reg. No. 35,483

NIXON PEABODY LLP  
8180 Greensboro Drive, Suite 800  
McLean, Virginia 22102  
(703) 790-9110

RECEIVED  
MAR 1 2001  
U.S. PATENT AND TRADEMARK OFFICE